

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant	:	Hayashi et al.
Appl. No.	:	10/561,830
Filed	:	December 22, 2005
For	:	POSITIVE RESIST COMPOSITION AND METHOD OF FORMING RESIST PATTERN USING SAME
Examiner	:	Thompson Rummel, P.
Group Art Unit	:	1795

**AMENDMENT AND RESPONSE TO OFFICE ACTION****Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed **January 28, 2008**, please consider the following amendments and remarks:

**Amendments to the claims** are reflected in **the listing of claims** which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.